

Notice of References Cited	Application/Control No. 09/854,813	Applicant(s)/Patent Under Reexamination JOHNSON ET AL.	
	Examiner Kripa Sagar	Art Unit 1756	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,963,788	10-1999	Barron et al.	438/48
	C	US-5,674,773	10-1997	Koh et al.	438/396
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.